

Notice of References Cited	Application/Control No. 10/593,809	Applicant(s)/Patent Under Reexamination NARAYAN ET AL.
	Examiner JONATHAN LANGMAN	Art Unit 1784

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,955,835	10-2005	Fartash, Arjang	427/250
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Tsukimoto et al., "Microstructure of Amorphous Tantalum Nitride thin films", Thin Solid Films, Vol. 460, 2004, pgs 222-226.
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.